



PATENT
2691-000013/US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Kohshi TAGUCHI et al.	Conf. No.:	Unknown
Application No.:	10/520,815	Group No.:	Unknown
Filing Date:	January 7, 2005	Examiner:	Unknown
For:	METHOD AND APPARATUS FOR FORMING SILICON NITRIDE FILM		

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314

February 22, 2005

ASSERTION OF SMALL ENTITY STATUS

Sir:

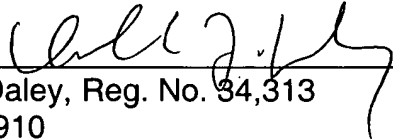
The above-identified application qualifies for small entity status. This written assertion of small entity status should satisfy the requirements of 37 C.F.R. § 1.27.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 08-0750 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17;

particularly, extension of time fees.

Respectfully submitted,

HARNESS, DICKEY, & PIERCE, P.L.C.

By 
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DJD/bof